SEPP5.001C1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Ritala et al.

Appl. No.

10/618,429

Filed

July 10, 2003

For

METHOD FOR GROWING THIN

OXIDE FILMS

Examiner

Robert M. Kunemund

Group Art Unit

1765

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 7, 2005

(Date)

Andrew N. Merickel, Reg. No. 53,317

RESPONSE TO OFFICE ACTION

Mail Stop Amendment

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on November 17, 2004. Applicants respectfully request entry of the attached Terminal Disclaimer and consideration of the following remarks.

Remarks/Arguments begin on page 2 of this paper.